



HB

Docket No.: 52352-785

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
George Jonathan KLUTH, et al. :
Serial No.: 10/071,207 : Group Art Unit: 2811
Filed: February 11, 2002 : Examiner:
For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE
CONTACTS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

10/071,207

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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